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U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE der the Paperwork Reduction Act of 1995. no persons are required to respond to a collection of information unless it displays a valid OMB control number. **Application Number** 10/634,220 TRANSMITTAL Filing Date August 5, 2003 **FORM** First Named Inventor Kryliouk et al. Art Unit (to be used for all correspondence after initial filing) **Examiner Name**

Total Number of Pages in This Submission			Attorney Docket Number		5853	5853-413			
ENCLOSURES (Check all that apply)									
	Fee Transmittal Form Fee Attached Amendment/Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s) Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53		Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Address Terminal Disclaimer Request for Refund CD, Number of CD(s) Remarks No fee is believed due. However, if any fee is any such fee and any additional fees due or cre 50-0951.		dress	Other Enclosure(s) (please Identify below): PTO/SB/08B; 3 References; and 1 Postcard			
-		SIGNA	TURE C	F APPLICANT, ATTOR	NEY, C	R AGEN	VΤ		
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Date March 30, 2004									
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PATENT IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: KRYLIOUK et al.

Application No.:

10/634,220

Examiner:

Filed:

August 5, 2003

Group Art Unit:

For: GROUP III-NITRIDE GROWTH ON SI SUBSTRATE USING

OXYNITRIDE INTERLAYER

CERTIFICATE UNDER 37/CFR 1.8(a)

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Neil R. Jette

Commissioner for Patents Post Office Box 1450 Alexandria, VA 22313-1450

Date: March 30, 2004

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to the Duty to Disclose under 37 C.F.R. §1.56, Applicants hereby disclose information that may be relevant to the Examiner's consideration of the above-identified application and the patentability of its claims.

In accordance with Rules 56, 97, and 98 of the Rules of Practice in Patent Cases (37 C.F.R. §§ 1.56, 1.97, and 1.98), Form PTO/SB/08B and copies of references cited therein are submitted for consideration by the Examiner. While the references provided in this Supplemental Information Disclosure Statement may be material to patentability pursuant to 37 C.F.R. § 1.56, it is not intended to constitute an admission that any reference referred to herein is prior art for this invention unless specially designated as such. Also, in accordance with 37 C.F.R. § 1.97(g), the filing of this Supplemental Information Disclosure Statement shall not be {WP174288;1}

In re Application of: KRYLIOUK et al. Application No.:

10/634,220

Filed:

August 5, 2003

Group Art Unit:

For: GROUP III-NITRIDE GROWTH ON SI SUBSTRATE USING

OXYNITRIDE INTERLAYER

construed to mean that a search has been made or that no other material information as defined in 37 C.F.R. § 1.56(a) exists.

This Supplemental Information Disclosure Statement is being filed before the issuance of a first office action on the merits of the application (37 C.F.R. 1.97(b)(3)); therefore, no fee is believed to be due. However, if any fee is due, the Commissioner is authorized to charge any such fee and any additional fees due or credit any overpayment to Deposit Account No. 50-0951.

Respectfully submitted,

Neil R. Jetter, Reg. No. 46,803 **AKERMAN SENTERFITT**

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Docket No. 5853-413

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Substitute for form 1449/PTO				Complete if Known		
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INF	ORMATION	DIS	CLOSURE	Filing Date	August 5, 2003	
STATEMENT BY APPLICANT				First Named Inventor	Kryliouk et al.	
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(Use as many sheets as necessary)			ecessary)	Examiner Name		
Sheet	1	of	1	Attorney Docket Number	5853-413	

		NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	r Cite No. Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
		KRYLIOUK et al., "SINGLE CRYSTAL GAN SUBSTRATE GROWN by HYDRIDE-METAL ORGANIC VAPOR PHASE EPITAXY (H-MOVPE)," Electromechanical Society Proceedings, 98-18:99-107, 1998.			
		LUKAS et al., "OPTIMIZATION OF PHASE DIAGRAMS BY A LEAST SQUARES METHOD USING SIMULTANEOUSLY DIFFERENT TYPES OF DATA," CALPHAD, 1:225-236, 1977.			
		SUNDMAN et al., "THE THERMO-CALC DATABANK SYSTEM," CALPHAD, 9:153-190, 1985.			

Examiner	Date	
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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